

<b>Information Disclosure Citation in an Application</b>	Application No. <b>10/664,126</b>	Applicant(s) <b>Todd</b>
	Docket Number <b>HES 2003-IP-010228U1</b>	Group Art Unit <b>1796</b>
<b>U.S. PATENT DOCUMENTS</b>		

	<b>DOCUMENT NO.</b>	<b>ISSUE/ PUB. DATE</b>	<b>NAME</b>	<b>CLASS</b>	<b>SUBCLASS</b>	<b>FILING DATE</b>
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	WO 00/57022	09/28/00	PCT	E21B	37/06	X
	WO 01/02698	01/11/01	PCT	E21B	43/27	X
	WO 01/94744	12/13/01	PCT	C09K	8/536	X
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